

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Ushio et al.  
Application No. New Application

Art Unit (Unknown)

Filed: June 13, 2001

For: LAYER-THICKNESS DETECTION  
METHODS AND APPARATUS FOR WAFERS  
AND THE LIKE, AND POLISHING APPARATUS

Examiner: (Unknown)

Date: June 13, 2001

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service on June 13, 2001 as First Class Mail in an envelope addressed to:  
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20231.

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11000 U.S. PTO  
09/881445  
06/13/01

INFORMATION DISCLOSURE STATEMENT  
FOR CONTINUING APPLICATIONS

COMMISSIONER FOR PATENTS  
WASHINGTON, DC 20231

Sir:

Listed on the accompanying form PTO-1449 are an English-language document and an English abstract for a Japanese document. Applicants respectfully request that such documents be listed as references cited on the issued patent.

The present application relies upon U.S. Patent Application No. 09/316,082, which was filed May 20, 1999, for an earlier filing date under 35 U.S.C. § 120. Furthermore, documents listed on the accompanying PTO-1449 Form were disclosed to or cited by the Patent Office in the earlier U.S. application. As a result, copies of the documents cited on the accompanying form PTO-1449 Form need not be sent to the Patent Office pursuant to 37 C.F.R. § 1.98(d). However, applicants will furnish the Patent Office with such copies upon request.

Please charge any additional fees which may be required in connection with filing this Information Disclosure Statement, or credit any overpayment, to Deposit Account No. 02-4550. A **duplicate** copy of this sheet is enclosed.

Respectfully submitted,

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<b>INFORMATION DISCLOSURE STATEMENT</b>  <b>BY APPLICANT</b>				Docket: 4641-59261		App: (Unknown)	
				Applicant: Ushio et al.			
				Filed: June 13, 2001		Art Unit: (Unknown)	
<b>U.S. PATENT DOCUMENTS</b>							
Init.*		Number	Date	Name	Class	Sub	Filed
		6,102,775	8/15/00	Ushio et al.			
<b>FOREIGN PATENT DOCUMENTS</b>							
		Number	Date	Country	Class	Sub	
		10311708	24.11.98	Japan (English Abstract Only)			
<b>OTHER DOCUMENTS</b>							
EXAMINER:				DATE			
*Examiner: Initial if considered, whether or not in conformance with MPEP 609; draw line through cite if not in conformance and not considered. Send copy.							